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CEDC 1002 PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

April 13, 2005

Application of Dennis R. Christensen Serial No. 10/706,239 Filed November 12, 2003 Confirmation No. 6388 For VAPOR DEPOSITION APPARATUS

Art Unit 1773

COMMISSIONER FOR PATENTS P.O. BOX 1450 ALEXANDRIA, VIRGINIA 22313-1450

SIR:

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

In accordance with 37 C.F.R. 1.97 and 1.98 and MPEP 609, and in compliance with the duty of disclosure set forth in 37 C.F.R. 1.56, applicant submits the attached PTO/SB/08A for consideration by the Patent and Trademark Office in the above-entitled application and to be made of record therein.

Applicant submits herewith copies of the foreign patent documents and literature references.

I certify that each item contained in this Supplemental Information Disclosure Statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Supplemental Information Disclosure Statement.

Respectfully submitted,

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PTO/SB/08A	Complete if Known		
INFORMATION DISCLOSURE	Application Number	10/706,239	
STATEMENT BY APPLICANT	Filing Date	November 12, 2003	
(use as many sheets as necessary)	Confirmation Number	6388	
OIFE	First Named Inventor	Dennis R. Christensen	
APR 1 3 2005 (L)	Group Art Unit	1773	
A STATE OF S	Examiner Name	Bret P. Chen	
Sheet 1 of 1	Attorney Docket No.	CEDC 1002	

		,, <u> </u>	U.S	. PATEN	T DOCUMENTS				
		U.S. Patent Document							
Examiner Initials*	Cite No.1		Number	Kind Code ² (if known)	Name of Patentee or Applicant of Cited Document MM-DD-YYYY		ited		
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Examiner Initials*	Cite No.1	Office	Number⁴	Kind Code ² (if known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	T⁵		
	29	EP	1 119 022		Hitachi, Ltd.	07-25-2001			
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Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.					Τ ⁶		
	30	European Search Report, February 25, 2005, 4 pages							

Examiner	Date	
Signature	Considered	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁵Applicant is to place a check mark here if English language Translation is attached or place an "A" here if English language abstract is attached..